

Angstrom Engineering 6-pocket E-Beam Evaporator



- The Angstrom E-beam is for thin-film evaporation in the range of 5 nm to several microns thick.
- A maximum of six different materials can be evaporated in one pump-down cycle, from the six pockets electron gun.
- The thickness of the metal is monitored in-situ by a thickness monitor.
 - Substrates up to 6 inch diameter can be attached to the substrate holder.
- The sample temperature usually does not exceed 50 °C.
- The following materials are available: Au, Pd, Ge, Ni, Pt, and Ti.